



2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Antonio L. P. Rotondaro

Docket No: TI-31133

Serial No: 10/001,483

Conf. No: 1903

Examiner: Michelle Estrada

Art Unit: 2823

Filed: 11/01/2001

For: METHOD TO IMPROVE THE UNIFORMITY AND REDUCE THE SURFACE ROUGHNESS
OF THE SILICON DIELECTRIC INTERFACEAMENDMENT UNDER 37 C.F.R. § 1.111RECEIVED
OCT 23 2003
TC 2800 MAIL ROOMCommissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)

I hereby certify that the above correspondence is being
deposited with the U.S. Postal Service with sufficient postage
as First Class Mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450, Alexandria, VA
22313-1450 on 10-15-03.
Ann Trent

Dear Sir:

Responsive to the Office Action mailed July 22, 2003, in connection with the
above identified application, Applicant respectfully submits the following remarks.

Amendments to the Specification:

None